



4319.700

## PATENT APPLICATION

### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Shin Ohnuki

Serial No.: 10/796,344

Conf. No.: 1978

Filed: 3/9/2004

For: VACUUM PROCESSING  
APPARATUS

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Examiner: Lund, Jeffrie Robert

) I hereby certify that this paper is being deposited with the  
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) date.

) 9/28/06

) Date

) F-CLASS.WCM

) Appr. February 20, 1998

Joseph P. Fort  
Registration No. 41,760  
Attorney for Applicant(s)

### AMENDMENT B

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the final Office Action mailed May 31, 2006, please amend  
the application as follows: